



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 13, 2025

IGI Report Number **LG739539322**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **MODIFIED EMERALD CUT**

Measurements **7.82 X 5.45 X 3.68 MM**

GRADING RESULTS

Carat Weight **1.53 CARAT**

Color Grade **E**

Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG739539322
100 FACETS**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa

LG739539322
Report verification at igi.org

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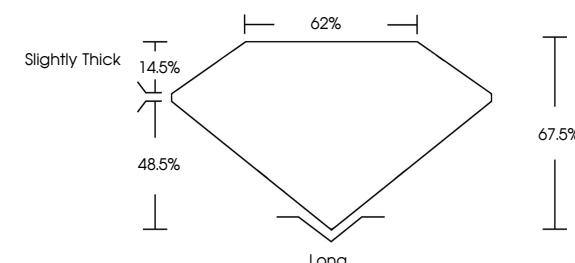
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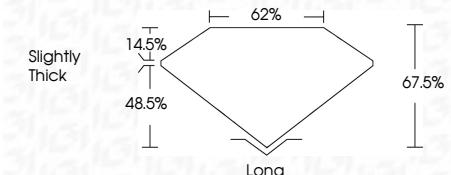
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PROPORTIONS



Sample Images Used



COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VS 1-2	VS 1-2	SI 1-2	I 1-3
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Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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[www.igi.org](https://igi.org)

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MODIFIED EMERALD CUT

7.82 X 5.45 X 3.68 MM

1.53 CARAT

E

VS 1

67.5%

62%

Slightly Thick

Long

EXCELLENT

EXCELLENT

NONE

None

100 FACETS

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IGI